

Notice of References Cited	Application/Control No. 09/987,914	Applicant(s)/Patent Under Reexamination OSHIMA ET AL.	
	Examiner William M. Brewster	Art Unit 2823	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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	D	US-			
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	F	US-			
	G	US-			
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	J	US-			
	K	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Stanley Wolf Ph.D. in Silicon Processing for the VLSI Era, Volume 2: Process Integration, Lattice Press, 1990, pp. 192-4.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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